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STA	TEMENT BY	A	PPLICANT		First Named Inventor	Sennana Koh et al		
					Group Art Unit	2874		
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				U.S. PATENT DOCUM	MENTS	
Examiner Initials	Cite No.1	U.S. Patent D Number	Nind Code ¹ (If known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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BH	2	5,416,8	161	Koh et al	05-16-1999	
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PH	9	5.832.1	49	Omizu et al	11-03-1998	
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Substitute for form 1449B/PTO				Complete If Known			
				Application Number	10/603.004		
INFO	DRMATIO	N DISC	CLOSURE	Filing Date	-na/04/2000 06/24/03		
STA	STATEMENT BY APPLICANT			First Named Inventor	Seungua Koh etal		
		D. A.	. 4.07	Group Art Unit	2874		
	(use as many sheets as necessary)			Examiner Name	Phan Palmer		
Sheet	2	ol	4	Attomey Docket Number	N/A		

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	r
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Examiner Signature	Phan T.H. Palmer	Date Considered	03/19/05
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Substitu	ate for form 1449B/	PTO		. Complete If Known				
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STA	STATEMENT BY APPLICANT			First Named Inventor	Seungua Koh etal			
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Substitute for form 1449B/PTO			•.	Complete If Known			
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USB as many sheets as necessary)			SCLOSURE	Filing Date	06/20/03		
			APPLICANT	First Named Inventor	Seungua Koh etal.		
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			as necessary)	Examiner Name	Phan Kalme		
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		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
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